

# The needs of scientists and engineers:

## And Equipment and Instrumentation

1.2  
starts  
here  
(no 1.1)

- Needs:
- slide 1 - Transfer of energy across multiple length scales
  - slide 2 - Combining top-down with bottom-up approaches
  - 3 - Interfacing biological and synthetic systems
  - 4 - Observing reactions/processes in real time (pico-seconds)
  - 5 - Increased resolution
  - and a long etc.
- } inter disciplines

Requirements: All these needs require the combination of expertise in different disciplines and combined efforts to advance equipment and characterization techniques.

In addition, scientists and engineers require space which is properly designed to enable interaction b/w different teams and allowing the sophistication required by advanced characterization and fabrication techniques.

Specific characteristics of buildings/space dedicated to research and development of nanotechnology:

### 1. INTERACTIVE SPACE slide 6 and video on it.

A state-of-the-art research and manufacturing center should combine technical (imaging, cleanroom, characterization, manufacture) and non-technical (offices, meeting rooms, ...) spaces in an effective way, with the main goal to promote interaction b/w different teams, as well as to facilitate transfer of systems b/w different technical spaces.

Below there is a list of different spaces that need to be included in a successful nano-research/manufacturing facility:

- Dry and wet labs
- semiconductor and bio-chem rooms (different)
- Quiet labs
- Tuning labs (imaging)
- Optical labs (metrology)
- Shielded labs (electronics) accessory)

In addition, such a facility should provide for external users and visitors from industry and academy, including government agencies, physics, chemistry, biology (and others) departments, etc.

Focusing on technical spaces, one needs to account for environmental considerations:

## [2] TEMPERATURE AND HUMIDITY

Let's take the example of a TEM, the technique most demanding in terms of T stability. (show picture of VCF TEM) slide 7

$$T = 20 \pm (0.01 \text{ to } 0.25)^\circ\text{C}$$

Temperature drift  $< 0.5^\circ\text{C}/\text{h}$  (fluctuation  $< 0.05^\circ\text{C}/\text{min}$ )

Heat generated by a 300 keV TEM column and support equipment are 500 W and 1000 W, respectively.

For this to be controlled, achieved, one needs to control:

- lifts
- heat transfer through walls
- high air exchange  $> 300 \text{ AC}/\text{h}$

Humidity is crucial for other instruments.  $\pm 1\%$  (good)  $\pm 5\%$  (ok)

### 3] ELECTRICITY AND EM NOISE

Many equipment units, and most importantly, measurement techniques, particularly regarding degree of sensitivity and accuracy, rely on a good control of the electrical power feeding the corresponding instrumentation.

Power disturbances occur from external and internal sources:

- External: lightning, faults, utility switch surges, ...
- Internal: mechanical equipment, elevators, lab equipment, ...

Several ways to reduce power disturbances:

- power conditioners,
- dedicated circuits
- shielded-isolation transformers
- uninterruptible power supplies (UPS) show in utility corridor

In addition, there are other external/internal sources of electromagnetic disruptions, such as:

- ground currents
- line signals (60Hz)
- ELF (extra low freq.) and EMI (electromagnetic interference) sources
- forces of heat (which translate in electrical disruptions),

Especially care needs to be taken when dealing with some nanotechnology processes, since these disruptions can be very problematic. Show example of noise and its effect in a STM measurement - slide 2

Electromagnetic Shielding (Faraday cage, shielding rooms.) show shieldy slide 3

For information on solving these issues go to [www.HDRINC.com](http://www.HDRINC.com)

## 14] VIBRATION AND ACOUSTICS

Many laboratory operations are sensitive to vibrations, and these are more important the higher the sensitivity or accuracy of the process is.

- Metrology
- TEM, SEM, STM (imaging)
- Lithographies (Ebeam, photo...)

Other equipment are also affected by vibrations, although to a lesser extent.

Sources of external vibrations are multiple:

- Machinery
- traffic
- human activity
- .....

The effect of mechanical vibrations depend on:

- amplitude
- duration
- frequency

Standards to describe recommended vibration criteria (VC)

benign vibration criteria curves: Given to architects to deal with vibrations.

Show a VC curve (slide 4)

Specific VC curves: For different equipment and techniques

Show VC curves in slide 5

It represents the rms velocity (calculated from  $v = 2\pi f \lambda$ ) in sets of one-third octave band. It is calculated within proportional band widths (Show curves in slides)

→ displacement  
max length

## 5] MECHANICAL NOISE

Noise is measured in bels, or decibels (dB)

$$1 \text{ dB} = 10 \log\left(\frac{I}{I_0}\right)$$

The sound-intensity-level dB (SIL) reference is standardized to the threshold intensity of hearing in humans in air, i.e., 1 kHz with  $I_0 = 10^{-12} \text{ W/m}^2$

The sound-pressure-level dB (SPL) relative to  $20 \mu\text{Pa}$ , is the minimum sound a human can hear in air (a mosquito 3m away)

- Sound sources are primarily coming from A/C, ventilation, machinery...
- Solutions:
  - acoustic mitigation covering (tiles, curtains, etc.)
  - silencers, narrower ducts channels, reducing air flow in A/C

## 6] CLEAN ROOMS

Clean spaces where the number of particles over a certain size is limited.

Show tables in slide 6-8

TO FINISH, SUMMARIZE ALL SPECIFICATIONS WITH slide 9

# CHAPTER 1 SUPPORT MATERIAL

slide 1 - TEM at VCF

video of TEM at work

show clean room and some support equipment in building (UPS)

slide 2 - STM change with EMI noise ...

[www.HDRImc.com](http://www.HDRImc.com) (info to eliminate power disruption)

slide 3 - EM shielding of a room

slide 4 - VC curve (generic)

slide 5 - VC curves (specific)

slides 6/8 - Clean rooms

slide 9 - all specifications together